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INFORMATION DISCLOSURE CITATION

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Applicant: Kenji YAMAZOE	
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U.S. PATENT DOCUMENTS

Examiner Initial		Patent Number	Publication Date	Name	Class	Sub-Class	Filing Date

FOREIGN PATENT DOCUMENTS

Examiner Initial		Patent Number	Publication Date	Country	Class	Sub-Class	Translation
M-1D	1	11-119411	04/30/1999	Japan (w/abstract)			☐ Yes ☐ No
							☐ Yes ☐ No
							☐ Yes ☐ No
							☐ Yes ☐ No
							☐ Yes ☐ No
							☐ Yes ☐ No

OTHER DOCUMENTS (Including Author, Title, Date, etc.)

M-1D	1	"SCAA Mask Exposures and Phase Phirst Design for 110nm and Below" M.D. Levenson et al., "Proceedings of SPIE, 4346, (2001), pp. 817-826..

Examiner	Date Considered 6/30/05

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP §609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

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